

#3IDS

1 of 1

Form PTO-1449

Docket Number (Sequence)

Application Number

TSMC-98-850/8528 09/982,680

Applicant

C.J. Lin et al.

Filing Date

08/20/01

Group Art Unit

2813

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

## U. S. PATENT DOCUMENTS

EXAMINER REMARK	DOCUMENT NUMBER	DATE	TITLE	CLASS	SUBCLASS	INDEX DATE & APPROPRIATE
MDP	5565369	10/15/96	Ko	437	30	8/7/95
MDP	579309	08/11/98	Gardner et al.	257	408	1/10/97
MDP	5851869	12/22/98	Urayama	438	238	9/24/96
MDP	5498554	3/12/96	Mei	437	34	4/8/94
MDP	5770502	6/23/98	Lee	438	264	5/31/96
MDP	5750435	5/12/98	Pan	438	525	7/14/97

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Portion of Pages, Etc.)


EXAMINER

Michael R. Legrand, Esq.

DATE CONSIDERED

5/25/2002

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